

<b>Notice of References Cited</b>	Application/Control No. 10/767,401		Applicant(s)/Patent Under Reexamination MOSTERT ET AL.	
	Examiner David S. Kim		Art Unit 2613	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,957,339 A	09-1990	Fussganger et al.	398/82
*	B	US-5,005,936 A	04-1991	Hsu, Hui-Pin	398/79
*	C	US-5,283,687 A	02-1994	Hsu et al.	359/341.2
*	D	US-5,317,440 A	05-1994	Hsu, Huy-Pin	398/41
*	E	US-5,633,741 A	05-1997	Giles, Clinton R.	398/79
*	F	US-5,949,563 A	09-1999	Takada, Tadayuki	398/7
*	G	US-6,097,533 A	08-2000	Atlas, Dogan A.	359/337
*	H	US-6,211,978 B1	04-2001	Wojtunik, Henry John	398/9
*	I	US-7,088,921 B1	08-2006	Wood, Thomas Huntington	398/67
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.